



4-25-07

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Docket No. 7956/Y01/DISPLAY/AHRDWR/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Inventor(s): Shinichi Kurita, Emanuel Beer, Edgar Kehrberg and Matthias Brunner
Title: METHODS AND APPARATUS FOR DETERMINING A POSITION OF A SUBSTRATE RELATIVE TO A SUPPORT STAGE
Serial No.: 10/782,503
Filed: February 19, 2004
Examiner: Emily Y. Chan
Group Art Unit: 2829

Transmitted herewith is:

- ☒ PTO Form 1449;
☒ Information Disclosure Statement with two cited references; and
☒ Return Postcard.

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	N/A	- 20 =	-0-	X \$50.00	\$0.00
Independent Claims	N/A	- 3 =	-0-	X \$200.00	\$0.00
Basic Filing Fee (\$300.00), Utility Search Fee (\$500.00), Utility Examination Fee (\$200.00)				\$1000.00	\$0.00
TOTAL FEES					PAID

 The Commissioner is hereby authorized to charge \$0.00 to Deposit Account No. 04-1696.

XX The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 04-1696.

XX Please address all future correspondence to:

Customer # 41161
Dugan & Dugan, PC
55 South Broadway
Tarrytown, NY 10591

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

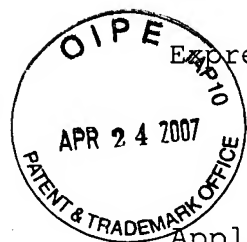
Express Mail Receipt No. EV977439787US

Date of Deposit: 4/24/07

Signature: Valerie G. Dugan

Respectfully submitted,

Valerie G. Dugan
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Express Mail Label No. EV977439787US

Docket No.:
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Applicant(s) : Shinichi Kurita et al.
Serial No. : 10/782,503
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For : METHODS AND APPARATUS FOR DETERMINING A
POSITION OF A SUBSTRATE RELATIVE TO A
SUPPORT STAGE
Group Art Unit : 2829
Customer No. : 41161
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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97,
applicants wish to call the attention of the Examiner to the
following references:

U.S. Patent No. 6,034,524, Barringer et al.

Foreign Art Reference No. JP 09-152569 (Japan)

Please charge deposit account No. 04-1696 in the amount of \$180.00 for consideration of this information disclosure statement under 37 C.F.R. § 1.97(c)(2).

These references are also listed on the accompanying Information Disclosure Statement (Form PTO-1449).

Consideration of the foregoing in relation to this patent application is respectfully requested.

Respectfully Submitted,

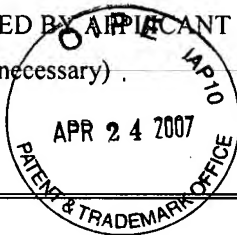


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Dated:

4/24/07
Tarrytown, New York

U.S. Department of Commerce, Patent and Trademark Office

LIST OF RELEVANT ART CITED BY APPLICANT
(Use several sheets if necessary)

Docket No.:

7956/Y01/DISPLAY/AHRDWR/RKK

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Applicants:

Shinichi Kurita et al.

Filing Date:

February 19, 2004

Group:

2829

U.S. Patent Documents

*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate
	US-4	6,034,524	3/7/2000	Barringer et al.			
	US-2						
	US-3						
	US-4						
	US-5						
	US-6						
	US-7						
	US-8						
	US-9						
	US-10						
	US-11						

Foreign Patent Documents

Translation

		Document Number	Date	Country	Class	Subclass	Yes	No
	F-1	JP 09-152569	6/10/1997	Japan			X	
	F-2							
	F-3							
	F-4							
	F-5							
	F-6							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	OT-1	
	OT-2	
	OT-3	

Examiner

Date Considered

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.